OMB No. 0651-0011

INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: 150.01160102	Serial No.: 10/680,038
	Applicant(s): Eugene P. Marsh	Confirmation No.: 8583
	Application Filing Date: October 7, 2003	Group: ~~2812~~ 2891
	Information Disclosure Statement mailed:	January 13, 2004

U.S. PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
DW		4,423,087	12/27/83	Howard et al.			
		4,471,405	09/11/84	Howard et al.			
		5,122,477	06/16/92	Wolters et al.			
		5,212,620	05/18/93	Evans, Jr. et al.			
		5,489,548	02/06/96	Nishioka et al.			
		5,520,992	05/28/96	Douglas et al.			
		5,554,564	09/10/96	Nishioka et al.			
		5,572,052	11/05/96	Kashihara et al.			
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		5,612,574	03/18/97	Summerfelt et al.			
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		5,969,419	10/19/99	Tijburg et al.			
		5,990,559	11/23/99	Marsh			
		6,001,461	12/14/99	Toyoda et al.			
		6,244,575	06/12/01	Vaartstra			
		6,402,126	06/11/02	Vaartstra			
DW		6,642,567	11/04/03	Marsh			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
DW		EP 0 618 597 A1	10/05/94	Europe			✓	
		EP 0 697 717 A1	02/21/96	Europe			✓	
		EP 0 697 718 A1	02/21/96	Europe			✓	
DW		EP 0795 896 A2	09/17/97	Europe			✓	

EXAMINER	Date Considered
Christian Wilson	5/25/05

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DW		JP 9 51079	02/1997	Japan				

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

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DW		Kaesz et al., "Low-Temperature Oranometallic Chemical Vapor Deposition of Transition Metals," *Mat. Res. Soc. Symp. Proc.*, 1989;131:395-400.
		Kravchuk et al., "Formation and physicochemical properties of Pt/ZeO_2 catalyst," *Zhurnal Prikladnoj Khimii*, 1995;68(*12*): 2009-2012. (English Abstract Only)
		Niemer et al., "Organometallic chemical vapor deposition of tungsten metal and suppression of carbon incorporation by codeposition of platinum," *Appl. Phys. Lett.*, 1992;61(*15*): 1793-1795.
		Pathangey et al., "Atomic Layer Deposition for Nanoscal Thin Film Coating," *Vacuum Technology and Coating*, May 2000: 32-41.
		Takasu et al., "Preparation of a novel $Pt\text{-}RuO_2/Ti$ electrocatalyst by use of highly porous ruthenium oxide support prepared from $RuO_2\text{-}La_2O_3$/electrode," *Journal of Alloys and Compounds*, 1997;261: 172-175.
		Versteeg et al., "Metalorganic Chemical Vapor Deposition by Pulsed Liquid Injection Using an Ultrasonic Nozzle: Titanium Dioxide on Sapphire from Titanium (IV) Isopropoxide," *J. Am. Ceram. Soc.*, 1995;78(*10*): 2763-2768.
DW		Precious Metal Labware Catalog from Alfa Aesar, 6 pgs, (Aug 2000).

EXAMINER	Date Considered
Christian Wilson	5/5/05

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